

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 7,348,595 B2
APPLICATION NO. : 10/828492
DATED : March 25, 2008
INVENTOR(S) : Sadami Takeoka et al.

Page 1 of 1

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On the Title page, in Item "(54)" ^{and Column 1, lines 1-5,} the title of the application, change
"SEMICONDUCTOR WIRING SUBSTRATE, SEMICONDUCTOR DEVICE,
METHOD FOR TESTING SEMICONDUCTOR DEVICE, AND METHOD FOR
MOUNTING SEMICONDUCTOR DEVICE" to --SEMICONDUCTOR DEVICE
AND METHOD FOR TESTING SEMICONDUCTOR DEVICE--;

In Item "(56) References Cited", change "2003/0008795 A1 01/2003 Asayama
et al." to --2003/0006795 A1 01/2003 Asayama et al.--; and

change "2003/0032283 A1 02/2003 Nagao et al." to --2003/0032263 A1
02/2003 Nagao et al.--.

This certificate supersedes certificate of correction
issued October 7, 2008.

[REDACTED]

[REDACTED]

[REDACTED]

[REDACTED]